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TC 1700

Patent  
Atty. Docket: H60-099 US

1765  
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**CERTIFICATE OF MAILING**

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By: Kim Turilli  
Dated: August 5, 2003

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Hans Martin BUSCHBECK, et al  
Serial No. : 09/975,885  
Filing Date : October 12, 2001  
Examiner : Matthew J. SONG  
Group Art Unit : 1765  
For : METHOD FOR PRODUCING COMPONENTS  
AND ULTRAHIGH VACUUM CVD REACTOR

**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

**AMENDMENT**

Sir:

Applicants hereby request, under 37 C.F.R. 1.136(a), a one (1) month extension of time within which to respond to the Office Action dated April 8, 2003; that is, up to and including August 8, 2003. A check in the amount of \$110.00 is enclosed to cover the official fee, as required by 37 C.F.R. 1.17(a)(1). The Commissioner is also hereby authorized to charge Deposit Account No. 14-1431 for any additional fees which may be

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due under 37 C.F.R. 1.16 or 1.17.

In reply to the Action of April 8, 2003, please amend the above-identified application,  
as follows: